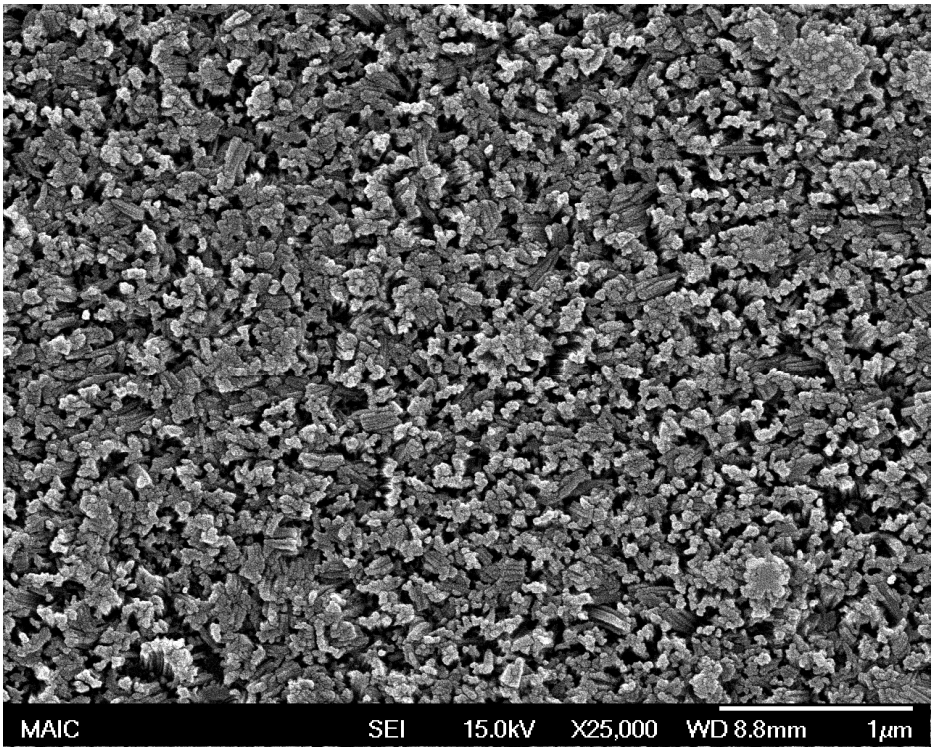

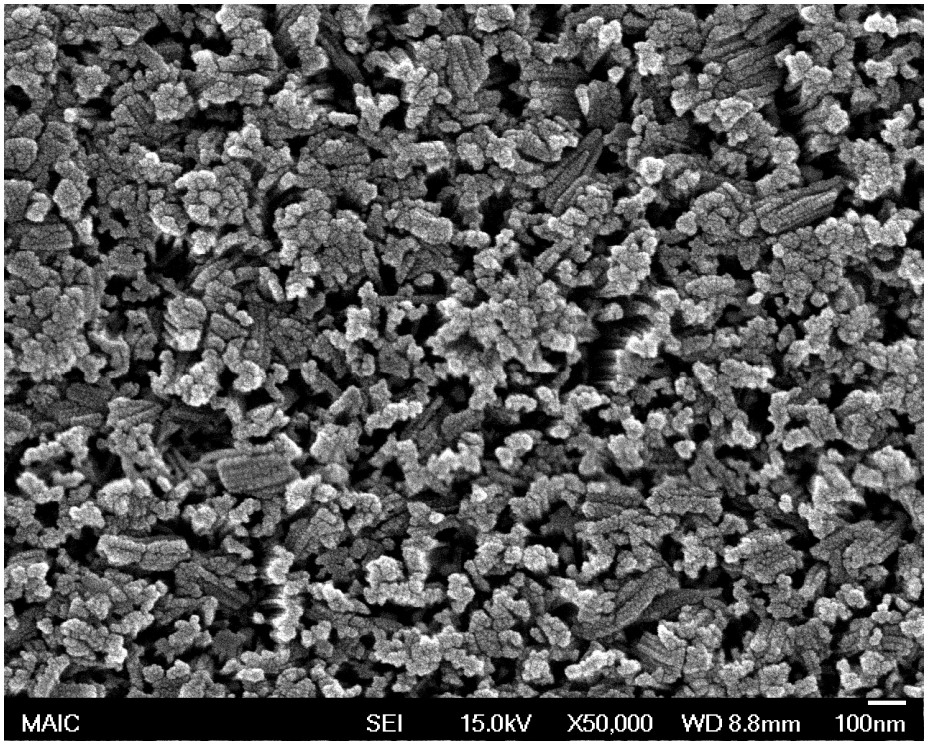

Figure S-1. Representative SEM pictures of pSi surface etched using HOME-HF method